


APPLICATION DATA SHEET

Electronic Version v14

Stylesheet Version v14.0

Title of Invention	PT COATING INITIATED BY INDIRECT ELECTRON BEAM FOR RESIST CONTACT HOLE METROLOGY	
Application Type : regular, utility Attorney Docket Number : FIS920030308		
Correspondence address: Customer Number: 29154 		
Inventors Information: <u>Inventor 1:</u> Applicant Authority Type: Inventor Citizenship: US Given Name: Wei Family Name: Lu Residence: City of Residence: Poughkeepsie State of Residence: NY Country of Residence: US Address-1 of Mailing Address: 8 Autumn Drive Address-2 of Mailing Address: City of Mailing Address: Poughkeepsie State of Mailing Address: NY Postal Code of Mailing Address: 12603 Country of Mailing Address: US Phone: Fax: E-mail: <u>Inventor 2:</u> Applicant Authority Type: Inventor Citizenship: US Given Name: Chester Family Name: Wasik Residence:		

City of Residence: Poughkeepsie
State of Residence: NY
Country of Residence: US
Address-1 of Mailing Address: 7 Scott Court
Address-2 of Mailing Address:
City of Mailing Address: Poughkeepsie
State of Mailing Address: NY
Postal Code of Mailing Address: 12601
Country of Mailing Address: US
Phone:
Fax:
E-mail:

Attorney Information:

practitioner(s) at Customer Number:

29154



as our attorney(s) or agent(s) to prosecute the application identified above, and to transact all business in the United States Patent and Trademark Office connected therewith.

Assignee 1:

Organization Name: International Business Machines Corporation
Address-1 of Mailing Address: New Orchard Road
Address-2 of Mailing Address:
City of Mailing Address: Armonk
State of Mailing Address: NY
Postal Code of Mailing Address: 10504
Country of Mailing Address: US
Phone:
Fax:
E-mail: